

**EAST Search History****EAST Search History (Prior Art)**

| Ref # | Hits | Search Query   | DBs                                      | Default Operator | Plurals | Time Stamp          |
|-------|------|--|--|------------------|---------|---------------------|
| L1    | 5085 | terada-y\$.in.   | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>21:56 |
| L2    | 42   | terada-y\$.in. and<br>polyimide  | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>21:56 |
| L3    | 714  | namikawa-m\$.in.   | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>22:01 |
| L4    | 20   | namikawa-m\$.in. and<br>polyimide  | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>22:01 |
| L5    | 103  | uenda-d\$.in.  | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>22:01 |
| L6    | 15   | uenda-d\$.in. and<br>polyimide   | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>22:02 |
| L7    | 148  | funatsu-a\$.in.  | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>22:02 |
| L8    | 4    | funatsu-a\$.in. and<br>polyimide   | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>22:02 |
| L9    | 12   | (releasable or<br>protective) same<br>((cleaning adj1 layer)<br>or polyimide) same<br>(support or backing)<br>same adhesive adj1<br>layer same (carrying<br>or semiconductor or<br>wafer or panel or<br>display) | US-PGPUB;<br>USPAT; EPO;<br>JPO; DERWENT | OR               | ON      | 2010/01/28<br>22:03 |

|     |       |  |                                    |    |    |                  |
|-----|-------|--|------------------------------------|----|----|------------------|
| L10 | 28    | (releasable or protective) same ((cleaning adj1 layer) or polyimide) same (support or backing) same adhesive adj1 layer and (carrying or semiconductor or wafer or panel or display) | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:04 |
| L11 | 12706 | (releasable or protective) and ((cleaning adj1 layer) or polyimide) and (support or backing) and adhesive and (carrying or semiconductor or wafer or panel or display)               | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:10 |
| L12 | 8511  | (releasable or protective) and ((cleaning adj1 layer) or polyimide) and (support or backing) and adhesive and (semiconductor or wafer or panel near3 display)                        | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:10 |
| L13 | 387   | (releasable or protective) same ((cleaning adj1 layer) or polyimide) same (support or backing) and adhesive and (semiconductor or wafer or panel near3 display)                      | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:11 |
| L14 | 0     | (releasable or protective) same ((cleaning adj1 layer) near8 polyimide) same (support or backing) same adhesive and (semiconductor or wafer or panel near3 display)                  | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:11 |

|     |    |  |                                    |    |    |                  |
|-----|----|--|------------------------------------|----|----|------------------|
| L15 | 2  | (releasable or protective) and (cleaning adj1 layer) near8 polyimide and (support or backing) and adhesive and (semiconductor or wafer or panel near3 display) | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:11 |
| L16 | 4  | (releasable or protective) and (cleaning adj1 layer) same polyimide and (support or backing) and adhesive and (semiconductor or wafer or panel near3 display)  | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:12 |
| L17 | 13 | (cleaning adj1 layer) same polyimide and (support or backing) and adhesive and (semiconductor or wafer or panel near3 display)                                 | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:22 |
| L18 | 9  | (cleaning adj1 layer) same polyimide same adhesive and (semiconductor or wafer or panel near3 display)   | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | ON | 2010/01/28 22:40 |

**EAST Search History (Interference)**

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**1/28/10 10:40:57 PM****C:\My Documents\EAST\Workspaces\10823654.1.wsp**